

INVENTOR INFORMATION

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CORRESPONDENCE INFORMATION

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APPLICATION INFORMATION

Title Line One:: METHOD OF REMOVING METAL ION AND APPARAT
Title Line Two:: US FOR TREATING SUBSTRATE
Total Drawing Sheets:: 7
Formal Drawings?:: Yes
Application Type:: Utility
Docket Number:: P/1596-68
Secrecy Order in Parent Appl.?:: No

PRIOR FOREIGN APPLICATIONS

Foreign Application One:: 2002-277283
Filing Date:: 09-24-2002
Country:: Japan
Priority Claimed:: Yes
Foreign Application Two:: 2003-201762
Filing Date:: 07-25-2003
Country:: Japan
Priority Claimed:: Yes

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